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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/779,842	02/18/2004	Jong Woo Kim	041501-5551-01	9434
9629	7590 07/26/2005		EXAMINER	
MORGAN LEWIS & BOCKIUS LLP			DUDEK, JAMES A	
	1111 PENNSYLVANIA AVENUE NW WASHINGTON, DC 20004		ART UNIT	PAPER NUMBER
WASIIINOI	1011, DC 20004		2871	
			DATE MAIL ED: 07/26/200	•

Please find below and/or attached an Office communication concerning this application or proceeding.

		AK						
	Application No.	Applicant(s)						
	10/779,842	KIM ET AL.						
Office Action Summary	Examiner	Art Unit						
	James A. Dudek	2871						
The MAILING DATE of this communication Period for Reply	appears on the cover sheet w	ith the correspondence address						
A SHORTENED STATUTORY PERIOD FOR RE THE MAILING DATE OF THIS COMMUNICATIO - Extensions of time may be available under the provisions of 37 CFF after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a - If NO period for reply is specified above, the maximum statutory per - Failure to reply within the set or extended period for reply will, by state of the period for reply will be set or extended period for reply wil	R 1.136(a). In no event, however, may a reply within the statutory minimum of third will apply and will expire SIX (6) MO atute, cause the application to become A	reply be timely filed ty (30) days will be considered timely. NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).	•					
Status								
1) Responsive to communication(s) filed on _								
	This action is non-final.							
3) Since this application is in condition for allo								
closed in accordance with the practice unde	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.							
Disposition of Claims	•							
4) ☐ Claim(s) 1-19 is/are pending in the applicat 4a) Of the above claim(s) is/are withe 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-19 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and	drawn from consideration.							
Application Papers								
9)☐ The specification is objected to by the Exam		•						
10)☐ The drawing(s) filed on is/are: a)☐ a								
Applicant may not request that any objection to	• • • • • • • • • • • • • • • • • • • •	· ·						
Replacement drawing sheet(s) including the cor	·							
11) The oath or declaration is objected to by the	Examiner. Note the attache	d Office Action of form P10-152.						
Priority under 35 U.S.C. § 119								
 12) Acknowledgment is made of a claim for fore a) All b) Some * c) None of: 1. Certified copies of the priority docum 2. Certified copies of the priority docum 3. Copies of the certified copies of the papplication from the International Bur 	ents have been received. ents have been received in a priority documents have been reau (PCT Rule 17.2(a)).	Application No received in this National Stage						
* See the attached detailed Office action for a	list of the certified copies no	received.						
Attachment(s)								
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) 		Summary (PTO-413) (s)/Mail Date						
2) Notice of Draitsperson's Patent Drawing Review (PTO-946) 3) Notice of Draitsperson's Patent Drawing Review (PTO-946) 3) Paper No(s)/Mail Date		Informal Patent Application (PTO-152)						

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DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1, 6, 9-11 and 15-18 are rejected under 35 U.S.C. 102(e) as being anticipated by US 20030025868A1 ("868")

Per claim 1, 868 teaches a method of fabricating a liquid crystal display device, comprising: preparing first and second substrates having an active area [P7] and a dummy area [region outside seal SL]; forming at least one first column spacer on the active area on the second substrate [see SP1; forming at least one second column spacer in the dummy area on the second substrate [see SP3]; forming a sealant in a periphery of the active area of the second substrate [SL]; and bonding the first and second substrates to each other [see figure 2].

Per claim 6, 868 teaches the method of claim 1, further comprising forming at least one third column spacer outside the active area of the second substrate [see SP2].

Per claims 9-10, 868 teaches the method of claim 1, further comprising forming a liquid crystal layer between the first and second substrates [see LC].

Per claim 11, 868 teaches the method of claim 1, further comprising forming a sliver pattern in a periphery of the active area of the first substrate [the sliver pattern is the small spaces between the spacers SP2 in figure 5].

Per claim 15, 868 teaches the method of claim 1, wherein the first column spacer is formed on the wiring part of the first substrate [see figures].

Per claim 16 and 17-18, 868 teaches the method of claim 1, further comprising: forming a black matrix and a color filter layer on the second substrate; and forming an overcoat layer on the color filter layer [see FIL, BM and OC2]. Claim 18 is inherent.

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Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 2-5, 7-8, 12-14 and 19 rejected under 35 U.S.C. 103(a) as being unpatentable over 868.

Per claims 2-3, 5 and 8 868 teaches the method of claim 1, but lacks the sealant formed of an organic photo-hardening sealant. However, it was well known to use mixtures of organic photo and thermo hardening seals to ensure a tight seal. Accordingly it would have been obvious to one of ordinary skill at the time of invention to combine the well known photo/thermo seal with 868.

Per claims 4 and 7, 868 teaches the method of claim 1, but lacks the first and second column spacers are about 5 to 30 microns in width. However it was a matter of design to when choosing the width. If the width is smaller, then the aperture increase and more light will pass. But the space accuracy will decrease. On the other hand, if the width in increase the less light will pass, but the space accuracy will increase. It would have been obvious to one of ordinary skill at the time of invention to choose a width between 5 and 30 microns.

Per claim 12, 868 teaches the method of claim 1, but lacks the steps of bonding the first and second substrates to each other includes: loading the second substrate on an upper stage of a bonding machine to face into the first substrate; loading the first substrate on a lower stage of

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the bonding machine; evacuating a chamber of the bonding machine; aligning the first and second substrates; and attaching the first and second substrates to each other. However, if not explicitly taught each of these method step are well known in the art to ensure proper gap spacing and alignment using an efficient method. Accordingly, it would have been obvious to one of ordinary skill at the time of invention.

Per claim 13, 868 teaches the method of claim 12, but lacks the step of venting the chamber to an atmospheric pressure to press the attached substrates by difference between an inner pressure of the bonded substrates and the atmospheric pressure and applying a UV-ray to the attached substrates to harden the sealant. However is was also well known to create a vacuum of at least one atmosphere to apply pressure on the substrates and use UV light to harden the seal to ensure the liquid crystal is seal properly. It would have been obvious to one of ordinary skill at the time of invention.

Per claim 19, 868 lacks the step of forming a dummy color filter layer on the periphery of the active area of the second substrate. However it would have been obvious to one of ordinary skill at the time of invention to form a color filter in the dummy region to form a light blocking layer.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to James A. Dudek whose telephone number is 571-272-2290. The examiner can normally be reached on 9:00-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert H. Kim can be reached on 571-272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-2197 (toll-free).

James A. Dudek Primary Examiner Art Unit 2871